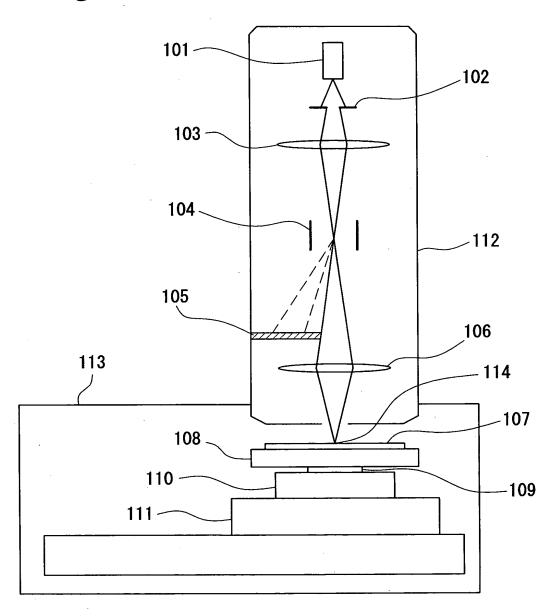
Fig. 1



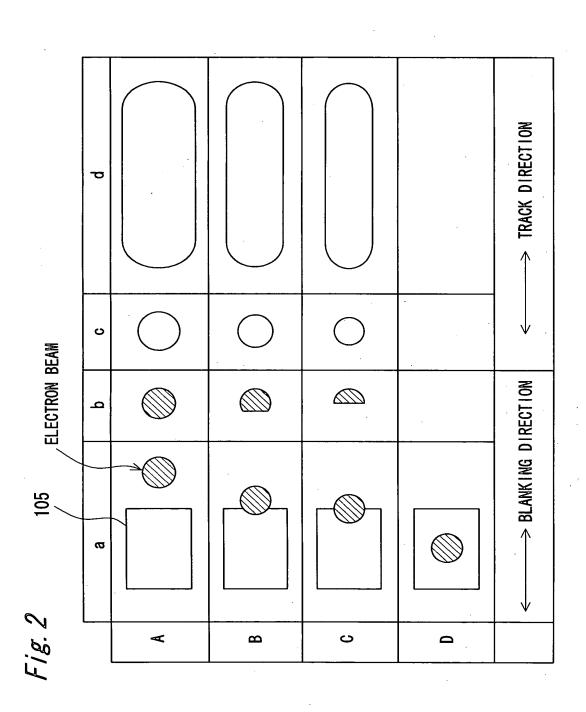
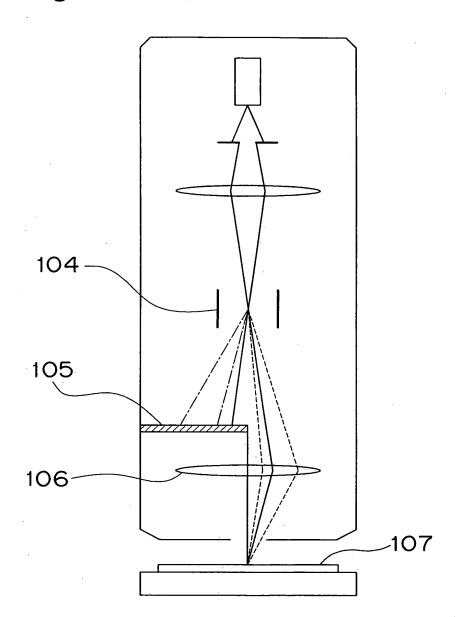


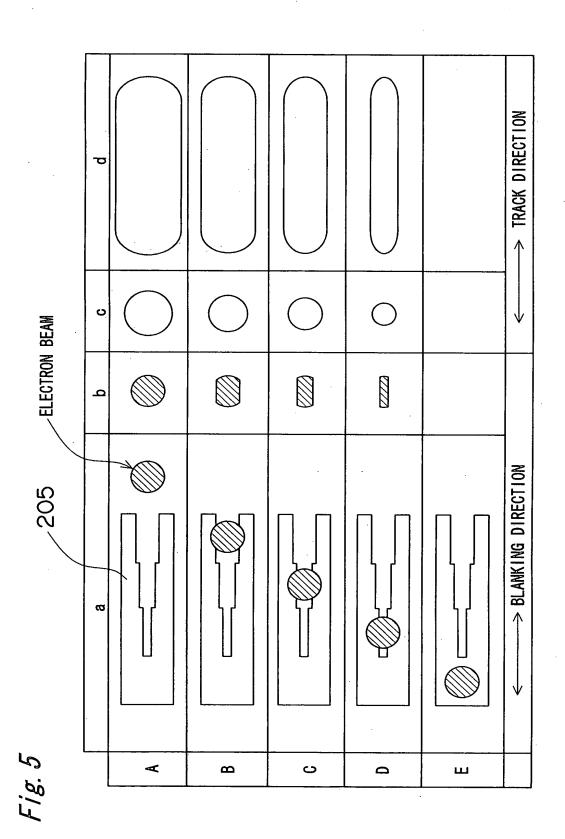
Fig. 3A	
	0
Fig. 3B	
Fig. 3C	

Fig. 4



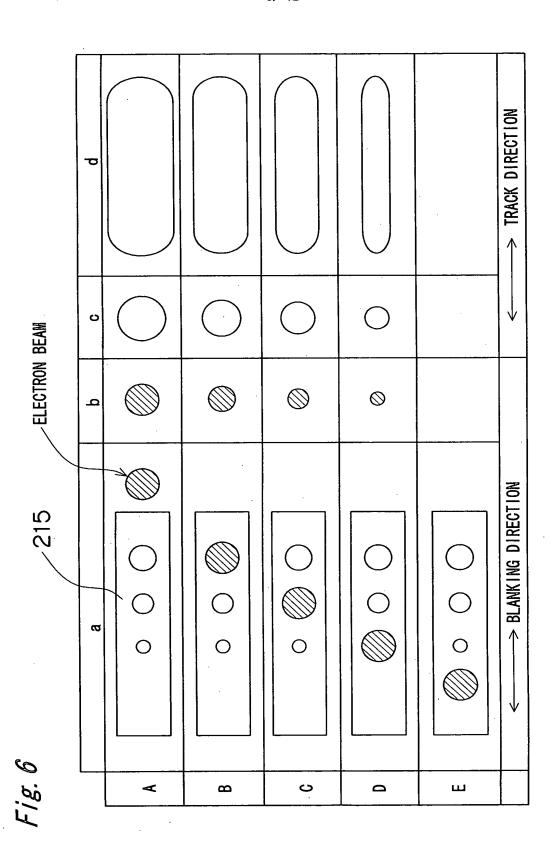
Eiichi ITO ELECTRON BEAM EXPOSURE METHOD AND ELECTRON BEAM EXPOSURE SYSTEM Our Ref.: AOY-3989US; Customer No. 23122

10/528548



Eiichi ITO ELECTRON BEAM EXPOSURE METHOD AND ELECTRON BEAM EXPOSURE SYSTEM Our Ref.: AOY-3989US; Customer No. 23122

Dur Ref.: AOY-3989US; Customer No. 23122 10/528548



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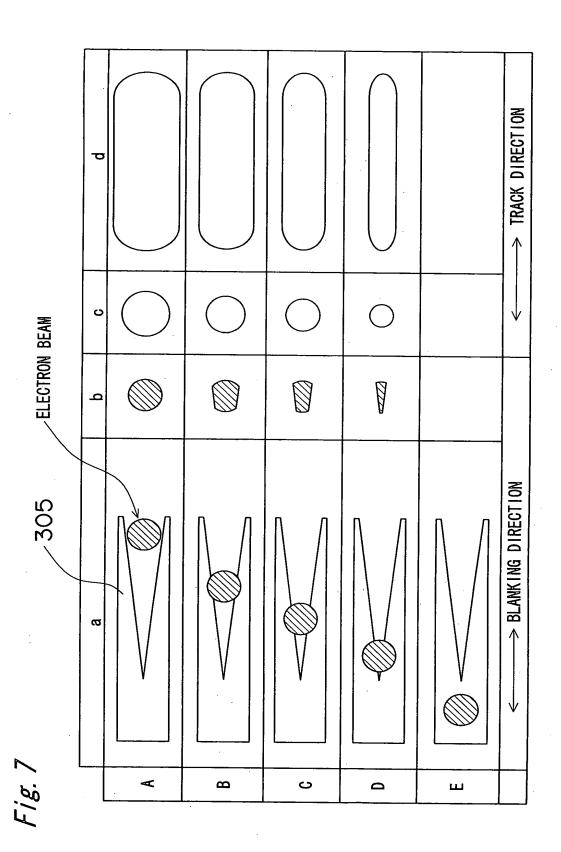
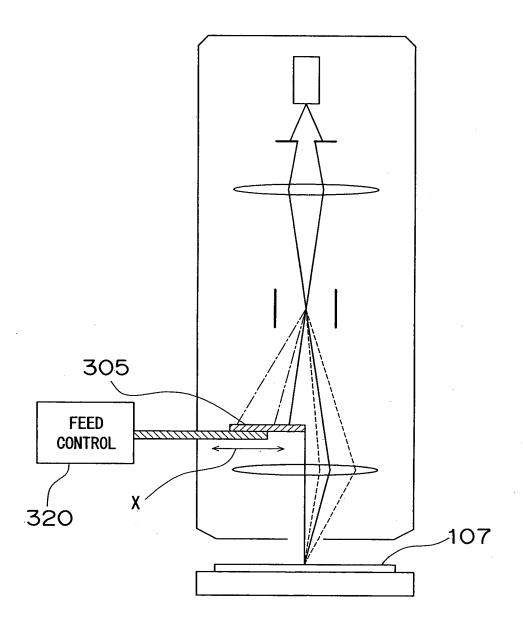


Fig. 8



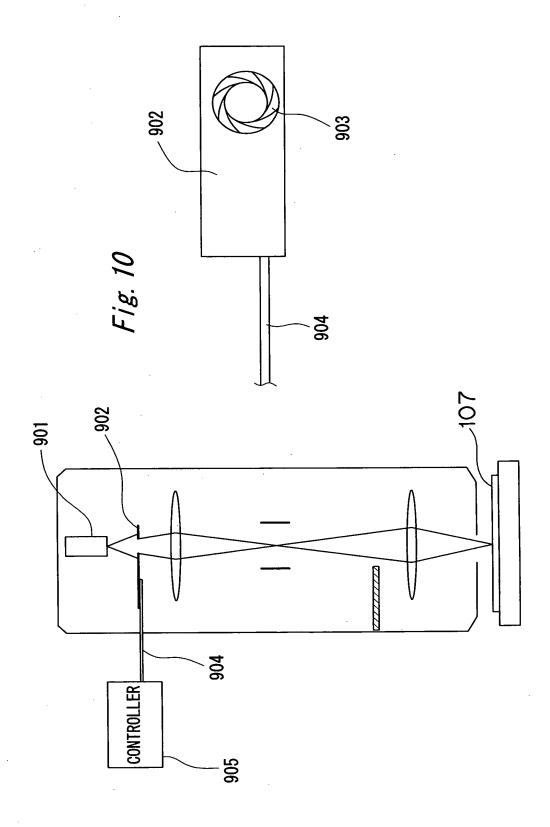
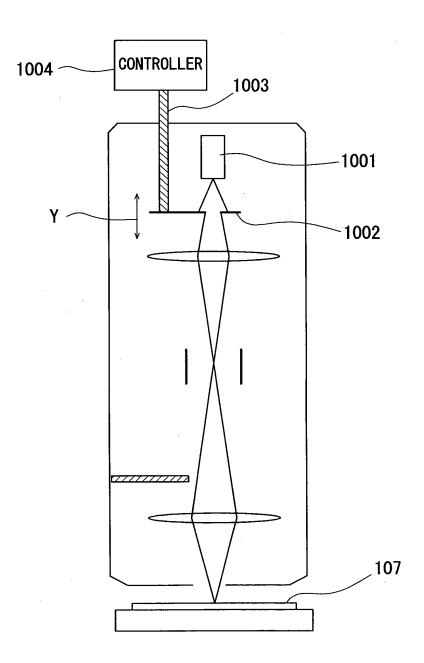


Fig. 11



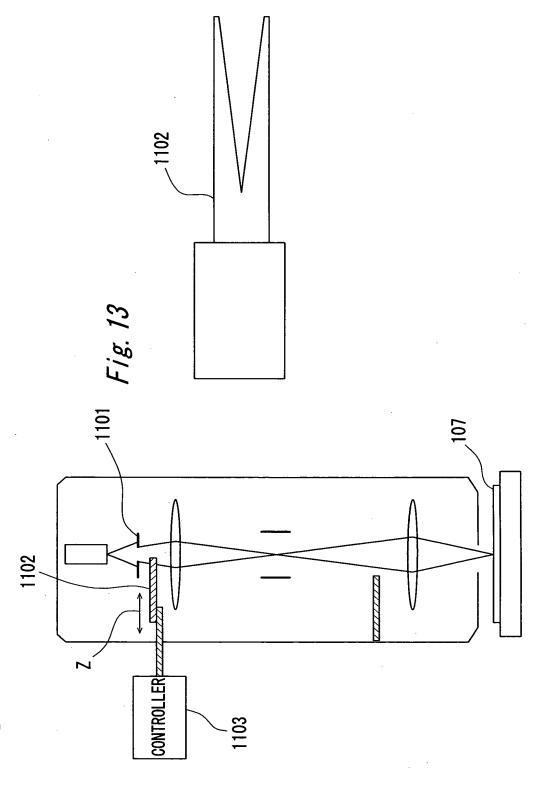


Fig. 12

Fig. 14 PRIOR ART

